EUROPEAN PLASMA RESEARCH **ACCELERATOR WITH** EXCELLENCE IN APPLICATIONS

Part II

C.Bortolin **F.Cioeta** L.Roscioli



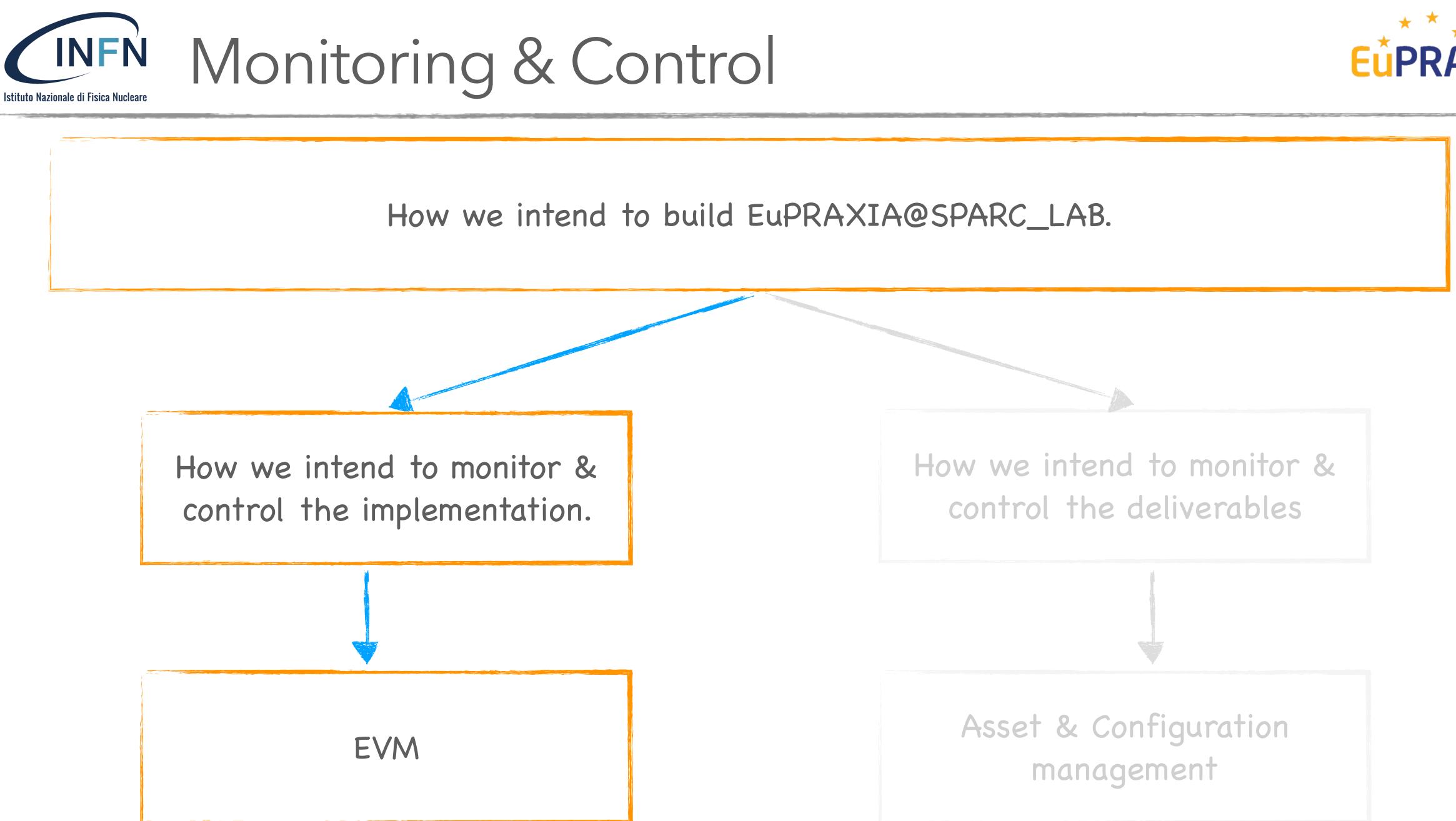
Istituto Nazionale di Fisica Nucleare



Eupraxia@Sparc_lab -1st Cost&Schedule Review Meeting

Antonio Falone (INFN - LNF), 11/12/2023











Monitoring & Control

is very high.

It requires a solid framework for monitoring and control a risk assessment.

(hopefully) robust EVM framework.

only we have to implement an EVM methodology but also design all the tools and processes.

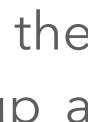


The implementation phase is a O(100M€) project over a long period. It consists of the procurement, integration, assembly and installation of a very large number of equipments -> System complexity

- Earned Value Management methodology seems to be most natural choice. Based on the experience we are developing with the EuAPS project we are now in the process to build up a

Note that there's no tool available in the institute to implement such methodology. Therefore not











Monitoring & Control

implementation of technical choices in the Project Management.

22,5 M€ / 30 months / financial and physical accounting every 2 months / all the tender to be adjudicated in the first year.

monitoring and control (EVM).



- EuAPS project is a good example on how external boundary conditions impose the

Given the aggressive requirements we had to start from scratch to build up a solid framework of





CINFN Monitoring & Control

Earned Value Management

implementation of the EVM methodology in our context.

1. NOT TECHNICALLY POSSIBLE to evaluate the actual effort of a single person on the project

2. Hardware based EVM + Follow up of the FTE allocated on personal basis.

cost for each WP is under discussion and hopefully can be implemented in the next years.



- Some constraints and boundary conditions have to be considered once approaching the
- 3. Actual costs for each WP at the moment are very risky to calculate. It requires a manual procedure from the Business Intelligence application. An automatic procedure to extract the actual







Monitoring & Control Tools

We have to rely on the e-tools available at INFN. This heavily relies on Microsoft Tools: Office, MProject for the web, power BI, Sharepoint, Power Automate

Some of them are quite new: training is in progress and will be further strengthen in 2024.

We are exploring the possibility to set up a consultancy contract with MProject expert to set up a robust EVM framework using MProject and PowerBI.

GOAL: Automatic (i.e. reproducible and repeatable) process to extract all the relevant data about project advancement. KPI and Dashboard production.







Monitoring & Control

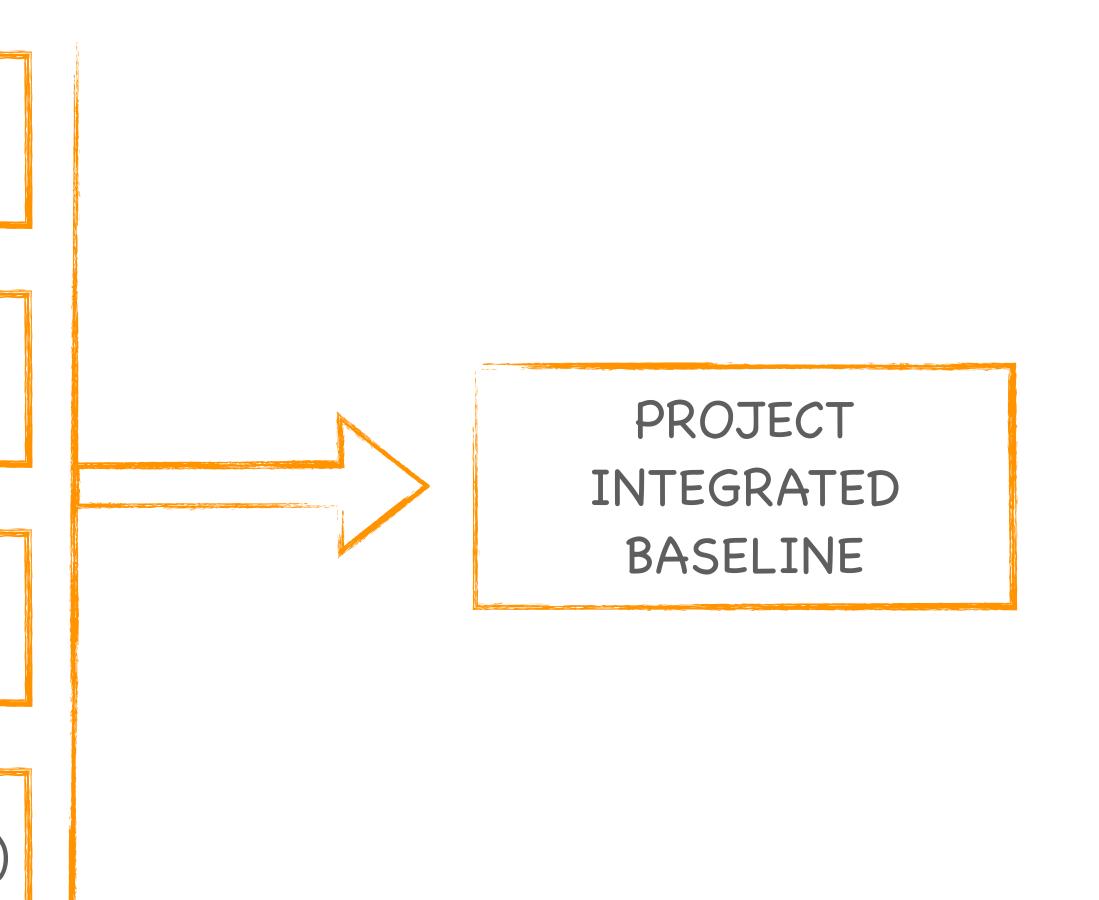
PBS & Configuration – Deliverable baseline

WBS Loaded - Work needed to produce the deliverable and FTE allocated

Time Schedule

PLANNED VALUE (Which include PBS and WBS Cost)

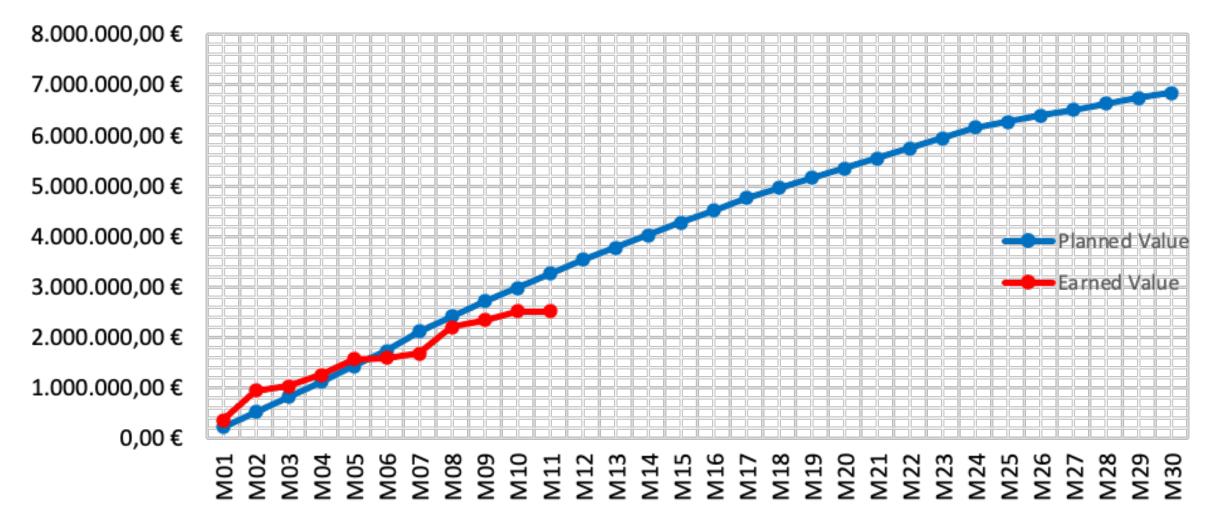








EVM WP 2



- Resource units reasonably allocated on subtasks (PV)
- Regular Bi-weekly updates (% Complete)
- Standard rate: Purchasing costs/100 and applied according to activity duration on sub-tasks
- Actual costs manually added after payments of invoices. •



		2023	3	2024			202		
1	▲ WP-1_Management & Dissemination								.
2	T-1.1_Project and Financing management								
9	▶ T-1.2_Dissemination & Communication								
13	- ▷ T-1.3_Data Management								
20	□ T-1.4_Alignment with EuPRAXIA-ESFRI Project		_			•	•		
26	▲ WP-2_Betatrom Radiation Source			· · · · · ·					
27	T-2.1_Start to End simulations	•							
28	IO-2.1.1_Hardware procurement and commissioning	•							
36	IO-2.1.2_Data analysis tools for betatron source characterization								
41	⊿ T-2.2_Plasma Source	•							
42	IO-2.2.1_Plasma source design	•							
47	IO-2.2.2_Gas jet test report	•				•			
52	IO-2.2.3_Laser Transport		•						
59	IO-2.2.4_Plasma Source Commissioning								
64	T-2.3_Timing & Synchronization	•							
65 72	 IO-2.3.1_Procurement of phase noise T-2.4_Online Photon Diagnostics 			-					
73	IO-2.4.1_Specs for test chamber and elect	• -			-				
79	▷ IO-2.4.2_Report on Design of gas monitor								
83	IO-2.4.3_Installation of electron and ion spectrometers in the test chamber				•				
88	IO-2.4.4_Commissioning of the electron a							•••••	
93	IO-2.4.5_Report on pilot experiments with								•
96	▲ T-2.5_Users and station	•							+
97	IO-2.5.1_Design User end station	•							
102	IO-2.5.2_Assembly of the chamber with in			<i>č</i>			9		
108	IO-2.5.3_Test end station report						—		+
113	T-2.6_Offline Photon Diagnostics	•							
114	IO-2.6.1_Design of cross-correlation meth	•			1				
120 135	 IO-2.6.2_Advanced photon diagnostics coll WP-3_High Power Laser Beam Line 							•	
136	4 T-3.1_Clean room realization								
137	▷ IO-3.1.1_Clean room design								
42	IO-3.1.2_Procurement and first payment			7					
48	▷ IO-3.1.3_Second payment			_	2				
151	▷ IO-3.1.4_Third payment								
154	IO-3.1.5_Assembling, commissioning and 1								
157	▲ T-3.2_Laser design and realization								
158	▷ IO-3.2.1_Design								
163	IO-3.2.2_Procurement and first payment			•		-			
69	IO-3.2.3_Second payment					ď	-		
172	IO-3.2.4_Third payment						*		
78	▲ T-3.3_Target system for high repetition rate	•							
79	IO-3.3.1_Design and procurement	•							
85	IO-3.3.2_Realization and tests								
190	4 T-3.4_Plasma Diagnostics	2							
191 200	IO-3.4.1_Design and procurement 4.1-3.5_Secondary beam Diagnostic								
200	▲ T-3.5_Secondary beam Diagnostic ▷ IO-3.5.1_Design, procurement and mecha								
210	 IO-3.5.2_Calibration under conventional t 					1			
	✓ WP-4_High Repetition Rate Laser Beam Line								_
18	▲ T-4.1_High rep rate laser system	•							
19	IO-4.1.1_Laser system tender and advance	• 							
25	IO-4.1.2_Laser second payment (30%)					*			
28	IO-4.1.3 Laser third (final) payment (50%)							•	
232	T-4.2 High rep rate laser system diagnostics	•				_			
33	▷ IO-4.2.1 Laser transport and manipulation	•							
237	IO-4.2.2_Definition and procurement of o			-					
246	▷ IO-4.2.3_Definition and procurement of Ia 4.7.4.3. High ron rate laser infrastructure and								
251 252	▲ T-4.3_High rep rate laser infrastructure and ▷ IO-4.3.1 Clean room commissioning (Bunk								
258	 IO-4.3.1 Clean room commissioning (Bunk IO-4.3.2 Procurement of optical tables 								
263	▷ IO-4.3.3 Procurement of vacuum pipes/pi							-	
268	▷ IO-4.3.4_Procurement of vacuum chambe								

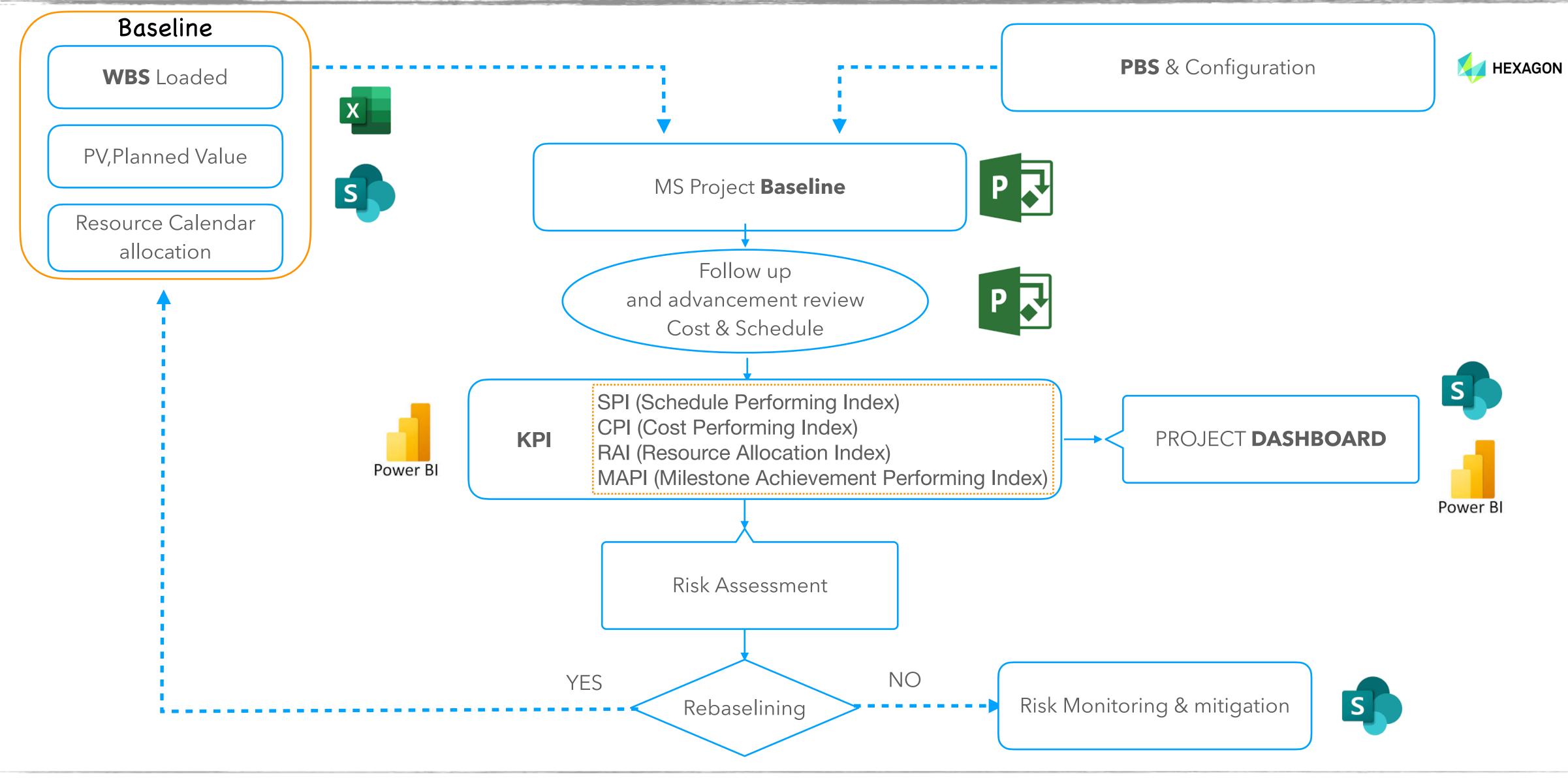
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Earned Value Management Framework









The advancement is assessed through regular follow up. The degree of advancement of each intermediate objectives is calculated in the following way in order to avoid personal bias and poor accuracy (-> Systematic error instead of random error).

Activity Status

Activity not started yet

Activity started and preliminary results

Activity started and consolidated results

Activity started, final results but not comp

Activity completed

Although the unavoidable approximation, so far it provided quite good results in terms of ability to assess the overall advancement of the project and production of reliable KPI.

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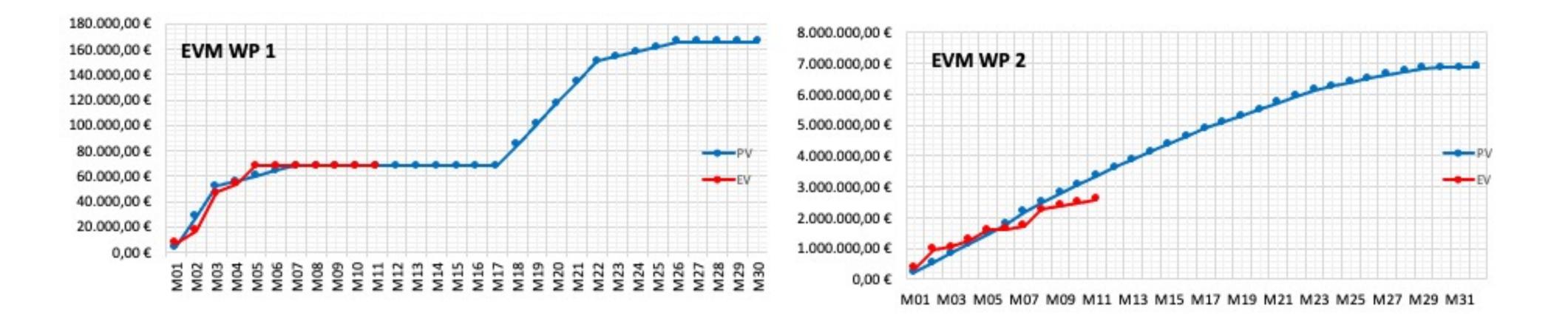
Earned Value Management Framework

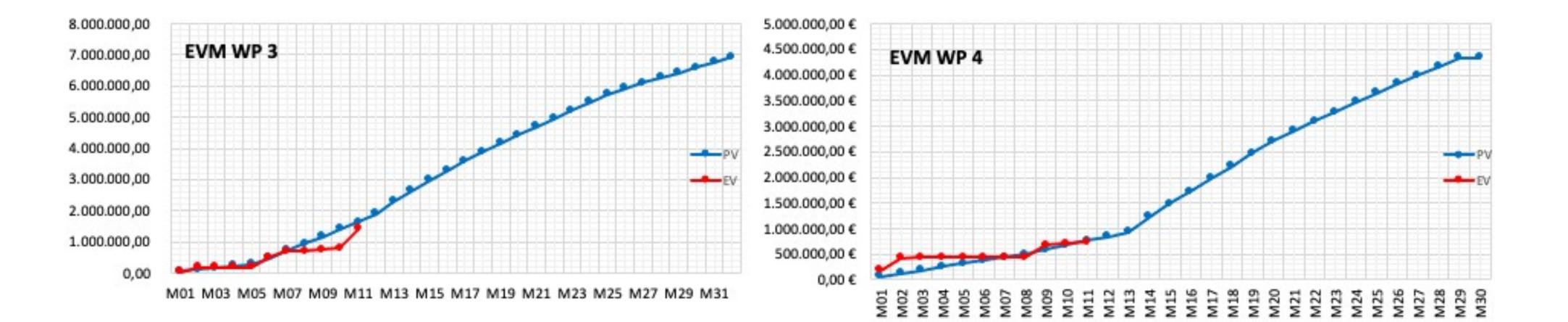
	% of Advacement
	0%
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	50%
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	100%





Typical Project Dashboard





1st CSR , 11/12/2023

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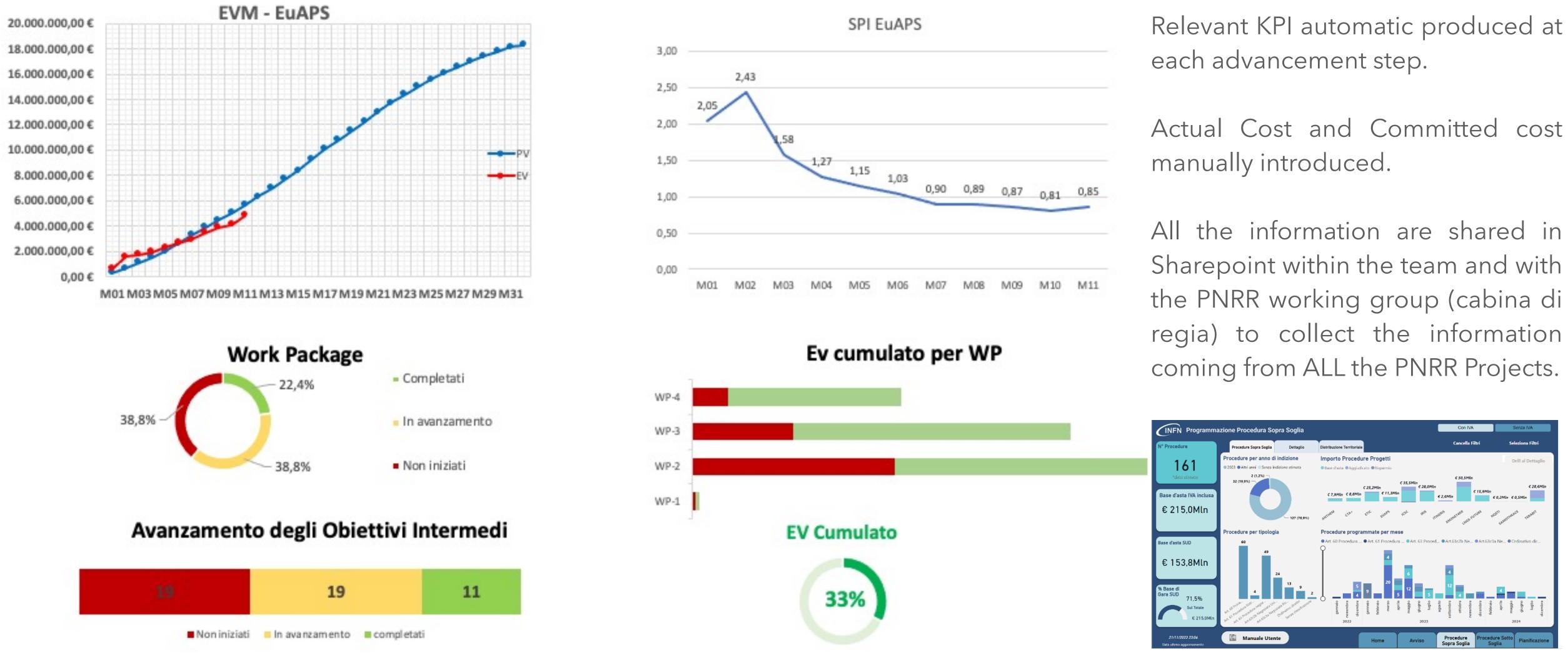
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Typical Project Dashboard INFŃ stituto Nazionale di Fisica Nucleare





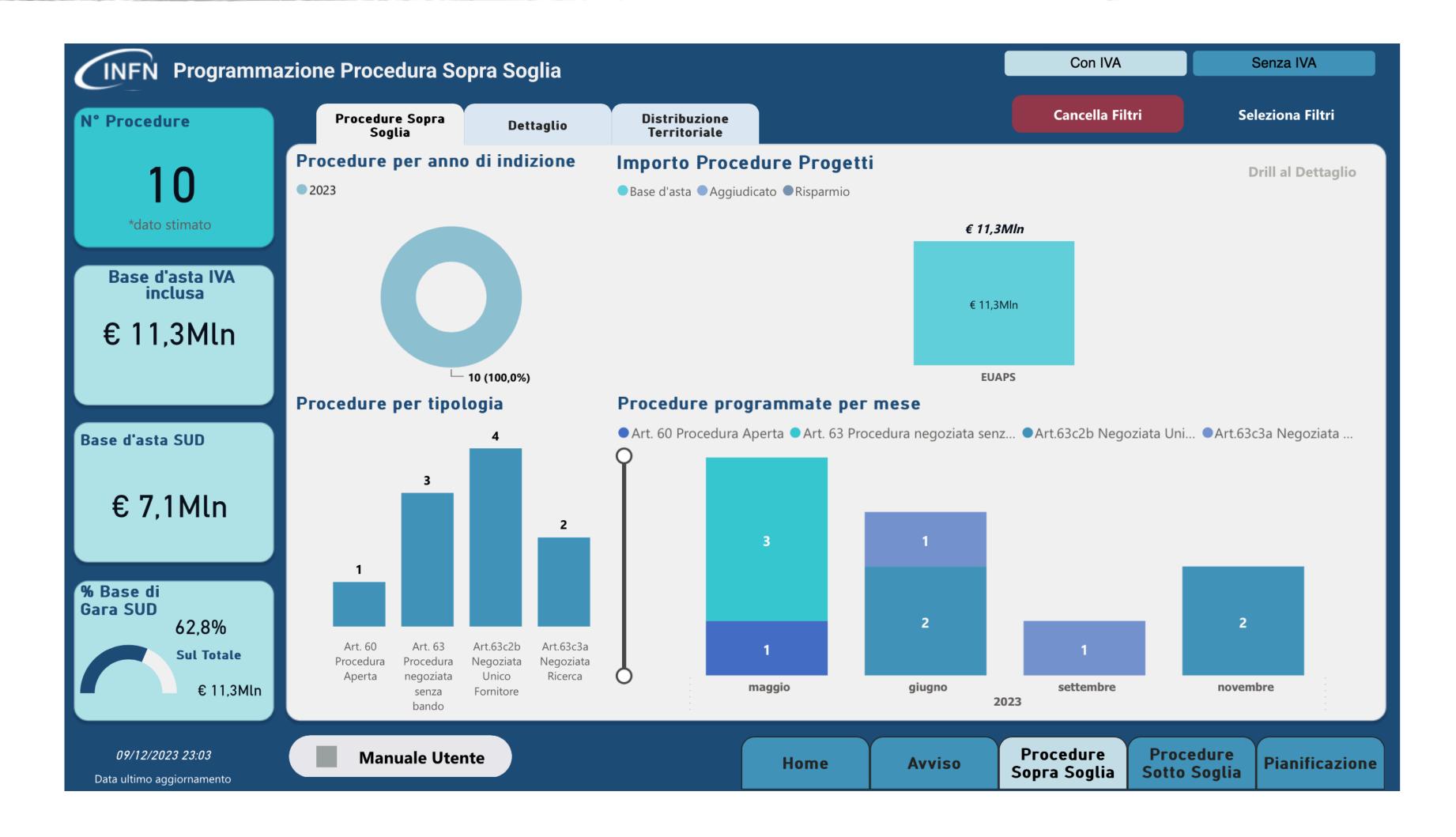




Typical Project Dashboard

Financial information at the moment are not correlated with the global EVM but are registered and monitored manually. KPI and Dashboard are also produced.

So far actual cost are very marginal.

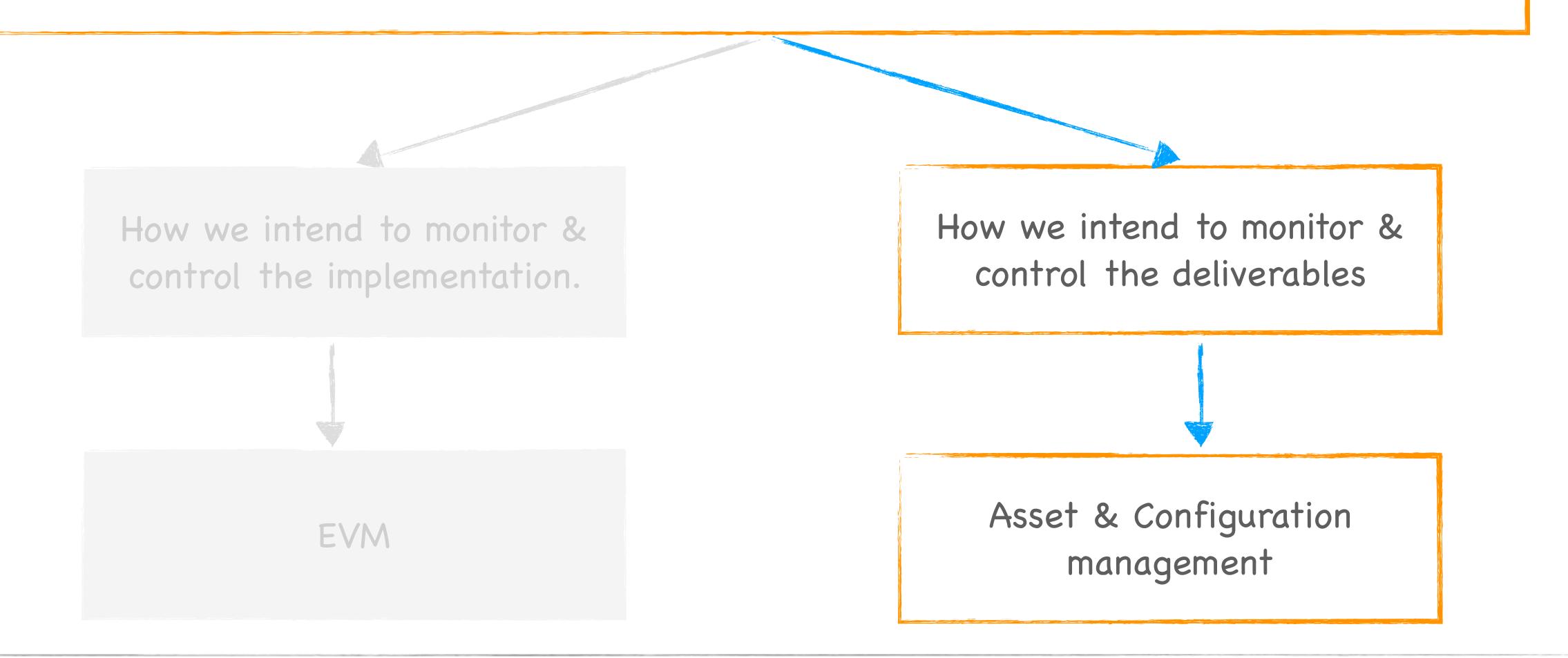








Asset & Configuration Management











Asset & Configuration Management

The <u>functional layout was developed using Viso Professional of Microsoft Office 365 as the project software. The</u> purpose of the functional layout is to give an immediate overview of machine elements in order to help to plan and to implement machine components that will be after listed in a specifics database.

In addition the functional layout helps for the identification of each object and its functionality in the machine.

Overall its main use can be summarized as follow:

- Machine configuration management and naming convention;
- Components database management Machine
- Components management related to ancillary elements (power supplies, cabling, controller, DAQ, etc...
- Budget management







Beam Optics simulations

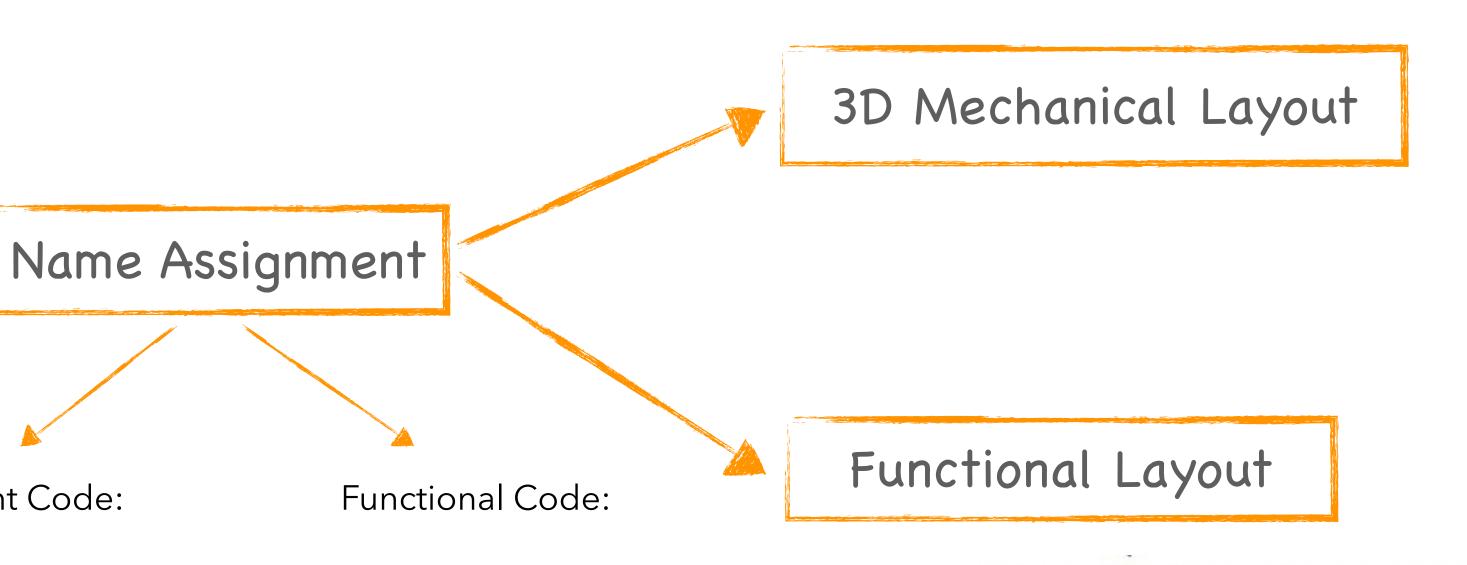
Components layout

Component Code:

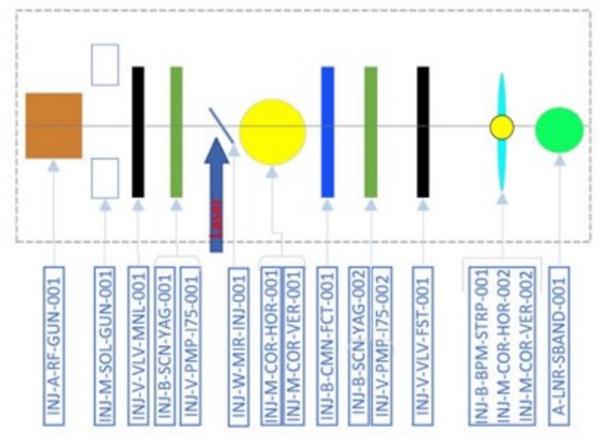
Codice Funzio	onale Codice Componente	nponente				
Zona/Area	Sistema Famiglia	Тіро	Numero Sequenziale			
	*					
INJ-	A - RF-	GUN	001			

It identifies the system as such. Identical components may have the same code.





Additional fields that determine the uniqueness of the component by identifying the zone or area of the machine where it is installed and where the component acquires its functionality.







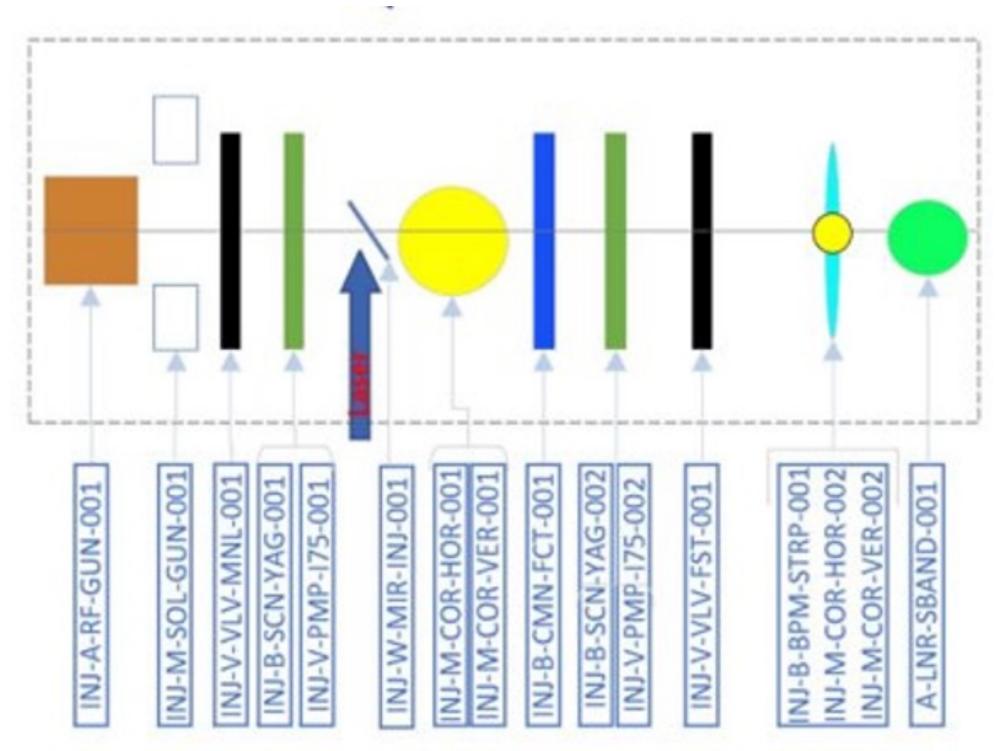
Each item of the PBS is then associated with the corresponding attributes:

- Data
- Requirements
- Specifications
- Interfaces
- Vendors
- QTY
- Etc...





- The hierarchical structure of the components database makes the PBS which is then reflected in the WBS.







Using specific software as a database (e.g. Hexagon INFOR-EAM), it is possible to create relationships between the various tables that collect requirements and components related to machine elements, so as to identify for each individual element the auxiliary components necessary at the proper operation and control as well as visualize all the components in the machine through the CAD interface. For each component therefore is possible to identified a specifics codes and attributes such as:

- UUID Code
- PBS Code
- WBS Code
- Moduls
- Longitudinal coordinate
- •Type of connectors
- Facility requirements (water flow, electrical power)

		WAC	WE VAREA.	+ SVS	TT FAM -	TYPE	TT SEOLIEN	PBS-CODE		₩ Z-C ₩ MODULS
1.1	1 REG	WA2	WP08 INJ	A	RF	GUN	001	INJ-A-RF-GUN-001	REGUN	0 INJ-LA-001
	2 120	WINE	INJ	Ŷ	PMP	120	001	INJ-V-PMP-120-001	ION PUMP GUN	D INJ-LA-DO
1	3 120		INU	v	PMP	120	002	INJ-V-PMP-120-001	ION PUMP GUN	0 INJ-LA-003
[4]	4 NEG		INU	v	PMP	NEG	002	INJ-V-PMP-NEG-001	NEXTOR Z100 GUN	0 INJ-LA-00
	5 NEG		INJ	v	PMP	NEG	002	INJ-V-PMP-NEG-002	NEXTOR Z 100 GUN	0 INJ-LA-00
4	6 SLG		INJ	M	SOL	GUN	001	INJ-M-SOL-GUN-001	SOLENOID GUN	D INJ-LA-DO
4	7 VMN		INU	V	VLV	MNL	001	INJ-V-VLV-MNL-001	MANUAL VALVE GUN	0 INJ-LA-00
	8 SYA		INJ	B	SCN	YAG	001	INJ-8-SCN-YAG-001	SCREEN GUN	0 INJ-LA-00
	9175		INJ	v	PMP	175	001	INJ-V-PMP-120-001	IONIC PUMP GUN	D INJ-LA-00
	10 MIR		INU	w	MIR	INU	001	INJ-W-MIR-INJ-001	MIRROR GUN	0 INJ-LA-00
[4]	11 CHO		INU	M	COR	HOR	001	INJ-M-COR-HOR-001	HORIZONTAL CORRECTOR GUN	
•	12 CVE		INJ	M	COR	VER	001	INJ-M-COR-VER.001	VERTICAL CORRECTOR GUN	D INJ-LA-00
4	13 CMN		INJ	B	CMN	FCT	001	INJ-B-CMN-FCT-001	CURRENT MONITOR GUN	D INJ-LA-00
[4]	14 SYA		INU	B	SCN	YAG	002	INJ-B-SCN-YAG-002	SCREEN GUN	0 INJ-LA-00
	15 175		INU	v	PMP	175	002	INU-V-PMP-175-002	IONIC PUMP GUN	0 INJ-LA-00
4	16 VFS		INJ	v	VLV	FST	001	INJ-V-VLV-FST-001	FAST VALVE GUN	D INJ-LA-DO
4	17 LNR		INU	Å	LNR	SBD	001	INJ-A-LNR-SBD-001	LINEARIZER	0 INJ-LA-00
4	18 BPM		INU	B	BPM	STP	001	INJ-B-BPM-STP-001	STRIPLINE GUN	0 INJ-LA-00
	19 CHO		INJ	M	COR	HOR	002	INJ-M-COR-HOR-002	HORIZONTAL CORRECTOR GUN	
4	20 CVE		INJ	M	COR	VER	002	INJ-M-COR-VER-002	VERTICAL CORRECTOR GUN	D INJ-LA-DO
	21 XBG		INU	A	ACC	XBD	001	INJ-A-ACC-X8D-001	XBAND GUN	0 INJ-LA-00
(H)	22 CHO		INJ	M	COR	HOR	003	INJ-M-COR-HOR-003	HORIZONTAL CORRECTOR LA00	
	23 CVE		INJ	M	COR	VER	003	INJ-M-COR-VER-003	VERTICAL CORRECTOR LADO2	D INJ-LA-DO
4	24 SOL		INJ	M	SOL	SEC	001	INJ-M-SOL-SEC-001	SOLENOID SBAND	D INJ-LA-00
(4)	25 SBD		INU	A	ACC	\$83	001	INJ-A-ACC-SB3-001	SBAND 3M LA002	0 INJ-LA-00
	26 CHO		INJ	M	COR	HOR	004	INJ-M-COR-HOR-004	HORIZONTAL CORRECTOR SB1	D INJ-LA-002
	27 CVE		INJ	M	COR	VER	004	INJ-M-COR-VER-004	VERTICAL CORRECTOR 581	D INJ-LA-DO
	28 SYA		INU	B	SCN	YAG	003	INJ-B-SCN-YAG-003	FIRST SCREEN LA002	0 INJ-LA-00
	29175		INU	v	PMP	175	003	INJ-V-PMP-175-003	ION PUMP SBND1	0 INJ-LA-00
	30 BPM		INJ	B	BPM	STP	002	INJ-B-BPM-STP-002	STRIPLINE LA002	D INJ-LA-00
	31 CHO		INU	M	COR	HOR	005	INJ-M-COR-HOR-005	HORIZONTAL CORRECTOR LA00	
[4]	32 CVE		INU	M	COR	VER	005	INJ-M-COR-VER-005	VERTICAL CORRECTOR LA002	0 INJ-LA-00
	33 CHO		INJ	M	COR	HOR	006	INJ-M-COR-HOR-006	HORIZONTAL CORRECTOR LA00	
4	34 CVE		INJ	M	COR	VER	006	INJ-M-COR-VER-006	VERTICAL CORRECTOR LADO3	D INJ-LA-00
100										

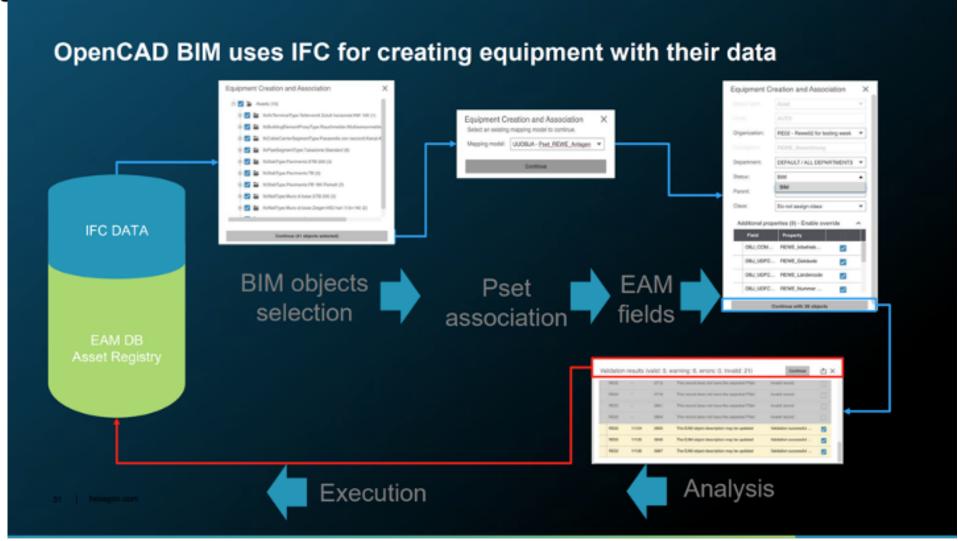
- Costs
- Status
- Suppliers



- Moreover is possible to link other document such as:
 - 1. Specifications
 - 2. Approved construction drawings
 - 3. Commercial documents (orders, specifications, etc.)

4. Quality documents (calibration certificates, certificates of conformity, etc.)

- 5. Warranty
- 6. Manuals







At the moment we have created the PBS tree and populated in some information (the ones available now).

We are in the process to migrate to a new solution: HxGN From Hexagon. This will allow a more custom-made configuration management approach. We can customize the data for each entry including technical details, administrative status, documentation and spare parts.



























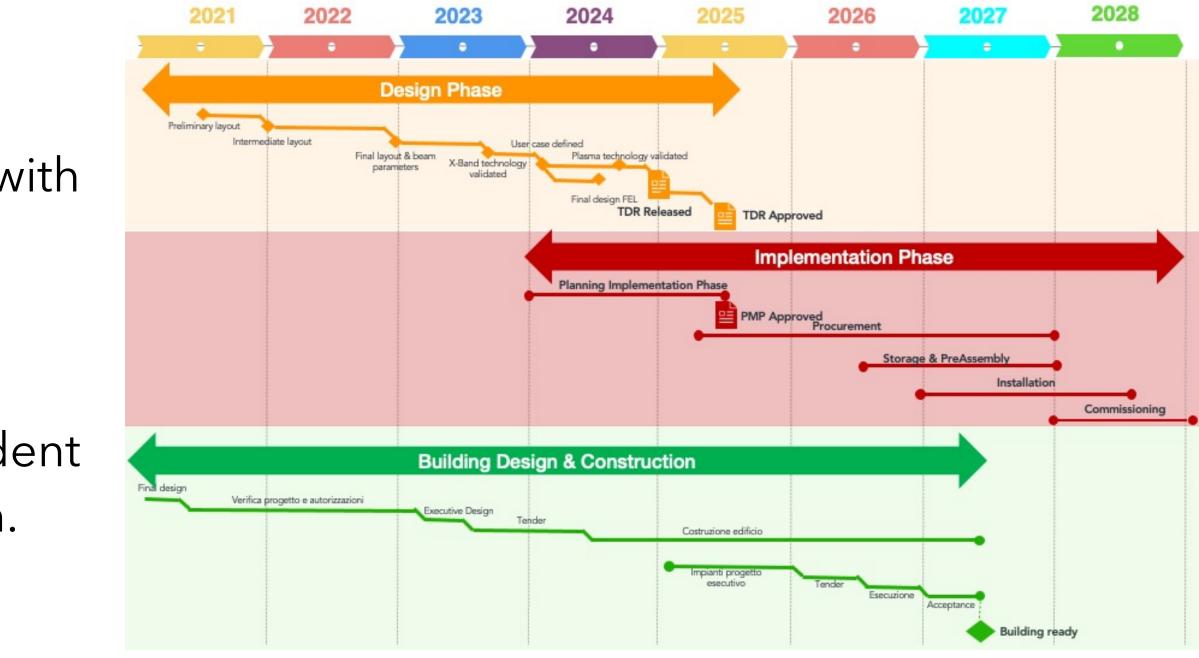


Project Management Plan is meant to be delivered with the TDR (during 2025).

Many things to be done, many of them are dependent on the machine development and building execution.

- Other things to be done are well known and a roadmap to cover all the topics has been done.
- sufficient at the moment.





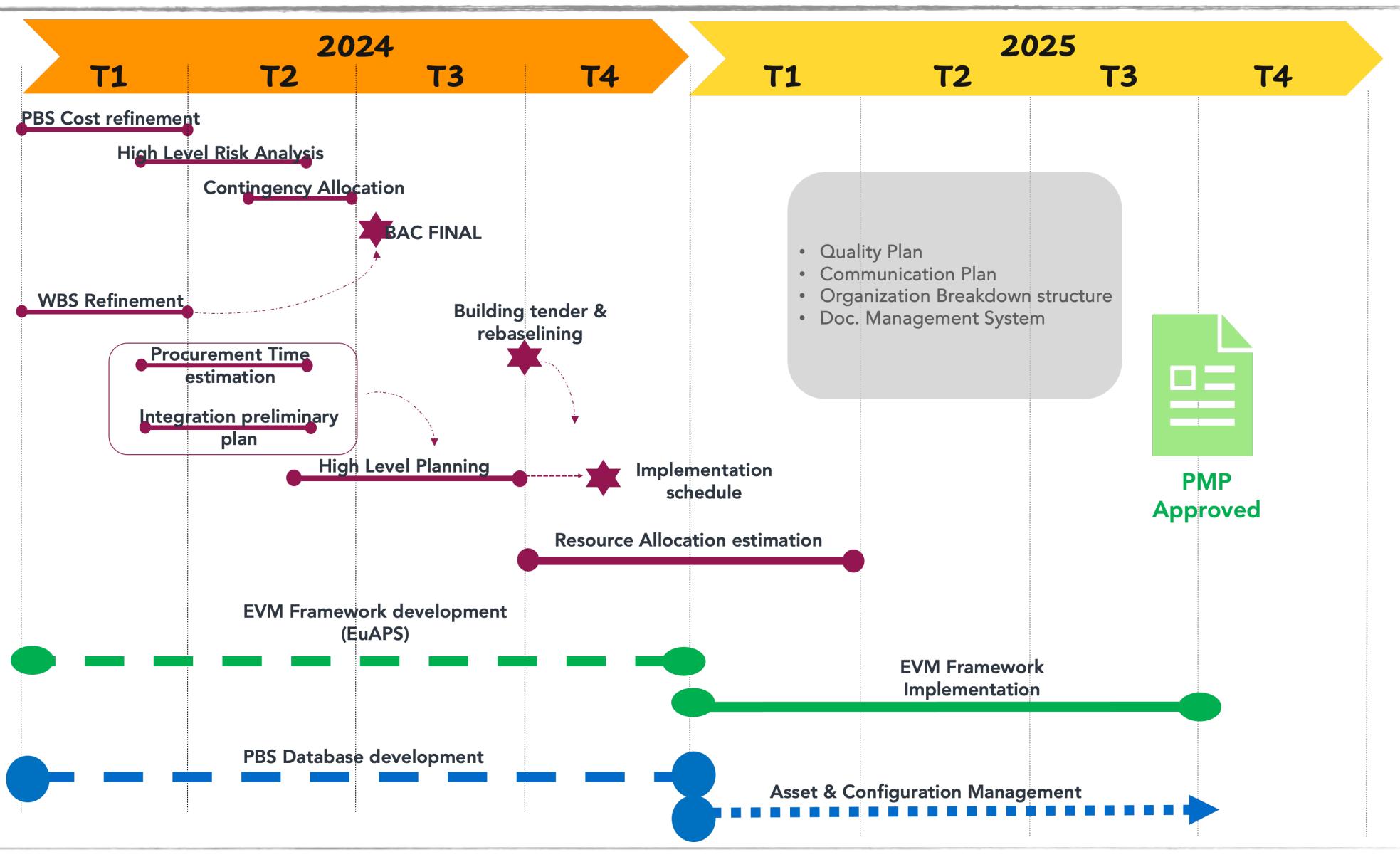
Some of these topics are out of the Project Office responsibility. In total 3FTE are allocated and it seems





Roadmap to Project Management Plan











Conclusions

Framework for EVM is almost complete

Full baseline and automated process require some e-tools that are under development.

• A full EVM is in principle possible but it requires some upgrade on the Business Intelligence APP.

Configuration and Assets management tool with HxGN will be fully exploited in 2024.



